In place of U. S. DEPARTMENT OF COMMERCE PTO-1449 PATENT AND TRADEMARK OFFICE Form			Complete if Known		
, 51		,	Application Number	10/719266	(IPE)
INFOR	RMATION DISCLOS	SURE	Filing Date	November 21, 2003	10 3
STAT	EMENT BY APPLIC	CANT	Applicant(s)	Nilardi Sarkar et al.	FEB 0 6 2004 3
(use as many sheets as necessary)			Art Unit	Junknewn 3700	
			Examiner Name	Unknown NGULFN	
SHEET	OF		Attorney Docket Number	34003.90	FRADEN

U. S. PATENT DOCUMENTS					
Examiner's Initials	Cite No	Document Number	Publication Date	Name of Palentee or Applicant of Cited Document	
W	AA	6,461,337	10/8/2002	Minotti et al.	
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	FOREIGN PATENT DOCUMENTS					
Examiner's Initials	Cite No.	Foreign, Ratent Document County Code Number - Kind)	Publication Date	Patentee or Applicant of Cited Document	Translation yn	

		OTHER PRIOR ART
Examiner's Initials	Cite // No.	Include name of the author (in CAPITALLETTERS); title of the article; title of the item date, page(s), volume- issue number(s), publisher, city/country where published
W.	AB AC	RYAN J. LINDERMAN et al., "OPTIMIZED SCRATCH DRIVE ACTUATOR FOR TETHERED NANOMETER POSITIONING OF CHIP-SIZED COMPONENTS", NSF Center for Advanced Manufacturing and Packaging of Microwave, Optical and Digital Electronics, University of Colorado at Boulder, CO. EMMANUEL QUEVY et al., "LARGE STROKE ACTUATION OF CONTINUOUS MEMBRANE FOR ADAPTIVE OPTICS BY 3D SELF-ASSEMBLED MICROPLATES", CIRMM/IIS-CNRS, Institute of Industrial Science, The University of Tokyo, Tokyo, Japan
W	AD	SHI-SHENG LEE et al., "MEMS ACTUATORS AND MICROPOSITIONERS FOR THE INTEGRATED MICRO-OPTICS", Electrical Engineering Department, University of California, Los Angeles
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Examiner Signature	HOANG	NEUTEN	Date Considered	10/29/04

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.